

SNS 102000000-SR0001-R00

# Spallation Neutron Source

## Systems Requirements Document for Equipment, Device and Signal Naming

MaySeptember 2000

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A U.S. Department of Energy Multilaboratory Project

SPALLATION NEUTRON SOURCE  
Argonne National Laboratory • Brookhaven National Laboratory • Thomas Jefferson National Accelerator Facility • Lawrence Berkeley National Laboratory • Los Alamos National Laboratory • Oak Ridge National Laboratory

**SPALLATION NEUTRON SOURCE  
SYSTEMS REQUIREMENTS DOCUMENT  
FOR EQUIPMENT, DEVICE AND SIGNAL NAMING**

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January 2000

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## 1. PURPOSE

This requirements document defines the equipment, device, and signal naming and numbering to be used for all SNS systems.

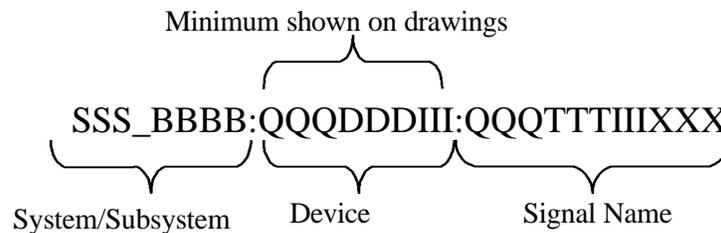
## 2. SCOPE

These requirements apply to all devices (beam instrumentation, sensors, actuators, etc.), equipment (power supplies, magnets, RF cavities, targets, moderators, instruments, etc.) and signals in technical systems and conventional facilities. These requirements do not apply to cable numbering, pipe numbering, or location designations throughout the facility.

The designations listed are to be used on operator screens, drawings, schematics, computer software, project databases, equipment name tags, test procedures, and other sources of information. ~~The complete name is intended primarily for use on operator screens to communicate device and signal information that is most applicable to operators. For best communication, names on drawings, name tags, and other information sources should be consistent with the complete name used by operators. However, as shown below, names used on drawings and equipment tags need not include the complete name.~~

## 3. REQUIREMENTS

Format and syntax shall be as shown on Figure 1. Only the device and/or signal name is required on drawings, name tags, etc. where the drawing or device name clearly indicates the system and subsystem including the equipment. However, where ~~a drawing for one system shows equipment in other systems,~~ the system and/or subsystem are not apparent the full name must be shown.



**Figure 1: Format and Syntax**

This naming convention does not specify minimum or maximum lengths of the name components. However, there is one practical restriction on the overall length of a signal name: EPICS version 3.13 can only handle signal names of less than or equal to 28 characters in length. While this restriction will probably be eliminated in a future version, signal names to be implemented in EPICS in the near term should be limited to a length of 28 characters or less.

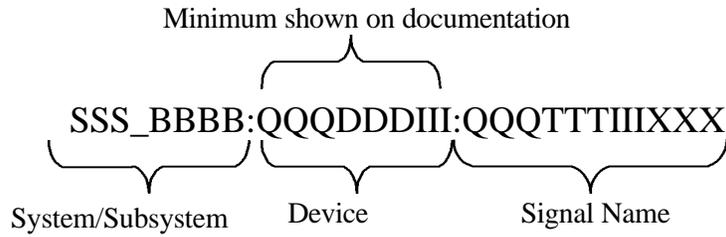
Requirements for specific naming elements are listed in Table 1 below.

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**Figure 1: Format and Syntax**

**Table 1. Numbering requirements**

Naming part	Description	Requirements	Controlled by
<b>Table 1. Numbering Requirements</b>			
Naming Part	Description	Requirements	Controlled by
Format and Syntax	Entire name	Figure 1 and Syntax rules in Table 2	Project Director
Format and Syntax	Entire name	Figure 1 and Syntax rules in Table 2	Project Director
SSS	System	Names in Table 3	Division Director
SSS	System	Names in Table 3	Division Director
BBBB	Subsystem	Names in Table 4.	Senior Team Leaders
BBBB	Subsystem	Names in Table 4. May be omitted if subsystem is obvious from system name or device name.	Senior Team Leaders
QQQ	Device Qualifier	Use is optional. Qualifiers are assigned by WBS Level 3 task leaders (Could be an associated piece of equipment)  Example: Sp1Tnk for spill tank or HX1_TE for temperature element on a heat exchanger.  Qualifiers are used to show facility location for cabinets (See SRD for Cabling, SNS 109010000)	Level 3 Task Leaders



<del>DDDD</del>	<del>Device Type</del>	<del>Names in Table 5 or IEEE 803 “Recommended Practice for Unique Identification in Power Plants and Related Facilities” or assigned by STL.</del>	<del>Senior Team Leader for Global Controls</del>
QQQ	Device Qualifier	Names in Table 5.	Senior Team Leaders
DDD	Device Type	Names in Table 6 or IEEE 803 “Recommended Practice for Unique Identification in Power Plants and Related Facilities” or assigned by STL.	Senior Team Leaders
<del>III</del>	<del>Device Instance</del>	<del>Number per Table 7. Numbers are assigned by Level 3 task leaders. They may be alphanumeric.</del>	<del>Level 3 Task Leaders</del>
III	Device Instance	Number per Table 10. Numbers are assigned by Level 3 task leaders. They may also be alphabetic.	Level 3 Task Leaders
<del>QQQ</del>	<del>Signal Qualifier</del>	<del>Use is optional. Qualifiers assigned by WBS Level 3 task leaders</del>	<del>Level 3 Task Leaders</del>
QQQ	Signal Qualifier	Use is optional. Example qualifiers shown in Table 7. Qualifiers assigned by WBS Level 3 task leaders.	Level 3 Task Leaders
<del>TTT</del>	<del>Signal Type</del>	<del>Table 6 or assigned by Level 3 Task Leader</del>	<del>Level 3 Task Leaders</del>
TTT	Signal Type	Table 8 or assigned by Level 3 Task Leader	Level 3 Task Leaders
III	Signal Instance	Use is optional. Assigned by WBS Level 3 task leaders.	Level 3 Task Leaders
<del>XXX</del>	<del>Suffix</del>	<del>Use is optional. Qualifiers assigned by WBS Level 3 task leaders ISA Standard S5.1 Instrumentation Symbols and Identification where applicable</del>	<del>Level 3 Task Leaders</del>

XXX

Signal Suffix

Use is optional. Example qualifiers shown in Table 8. Qualifiers assigned by WBS Level 3 task leaders.

Level 3 Task Leaders



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~~3. Letter case shall not be used to distinguish between names. That is, there shall never be two names for which the only difference is letter case.~~

~~4. Letter case shall be used to improve readability. The first letter of a word or~~

---

~~abbreviation shall be capitalized; succeeding letters shall be lower case. Acronyms shall be all capital letters.~~

- ~~5. The only non-alphanumeric character used shall be “\_”, which can be used as desired to improve readability (but not as a first character).~~

**Table 3. System codes**

<b>WBS</b>	<b>System code</b>	<b>System code description</b>
<b>WBS</b>	<b>System Code</b>	<b>System Code Description</b>
1.3	FE	Front End
1.3	LEBT	LEBT
1.3	MEBT	MEBT
<del>1.3</del>	<del>RFQ</del>	<del>RF quadrupole</del>
1.3	RFQ	RF quadrupole
1.3	Src	Ion source
1.4	Lin	Linac
1.4	DTL	Drift tube linac
1.4	CCL	Coupled cavity linac
1.4	SCL	Superconducting linac
1.4	SCMB	Medium Beta linac
1.4	SCHB	High Beta linac
1.4	SCWM	Superconducting warm section
1.4	CHL	Central Helium Liquefier
1.5	HEBT	HEBT
1.5	Ring	Ring
1.5	RTBT	RTBT
1.6	Tgt	Target systems
1.6	EDmp	Ring extraction dump
1.6	IDmp	Ring injection dump
1.6	LDmp	Linac dump
1.7	ISF	Instrument Support Facilities
1.7	Instr	Instruments
1.8	CF	Conventional Facilities
1.8	Util	Utility systems
1.8	Elec	Power and communication
1.8	Inst	Instrumentation and controls
1.8	Mech	HVAC and utilities systems
1.8	Wste	Waste systems
1.9	ICS	Integrated Control System
1.9	EPS	Equipment Protection System
1.9	PPS	Personnel Protection System

**Table 4. Subsystem codes**

<b>Subsystem code</b>	<b>Subsystem description</b>
<b>Subsystem Code</b>	<b>Subsystem Description</b>
Subsystems used in multiple systems	
Accl	Accelerator
Chop	Chopper
<del>Cryo</del>	<del>Cryogenics</del>
Ctl	Control system
Diag	Diagnostics
DIWS	Deionized Water System
Gen	General
Mag	Magnets
<del>MCR</del>	<del>Main control room</del>
PS	Power Supply
RF	RF systems
Tim	Timing
Vac	Vacuum

Front End Specific Subsystems

<u>Subsystem code</u>	<u>Subsystem description</u>
Subsystem Code	Subsystem Description
Bnch	(MEBT) Buncher
FE	Front End
Cool	(RFQ) H2O
<del>PMS</del>	<del>(RFQ) PMR</del>
PMR	(RFQ) Pi-Mode Rods
Vane	(RFQ) Vane
Wall	(RFQ) Wall

#### Linac Specific Subsystems

2KCB	2K Cold box
4KCB	4K Cold box
CCL	Coupled cavity linac
CMn	Cryomodule #n
DTL	Drift tube linac
GM	Gas management system
HB	High Beta
IGBT	Insulated gate bi-polar transistor
Lin	Linac
MB	Medium Beta linac
SCL	Superconducting linac
<del>PPS</del>	<del>Personnel Protection System</del>
SCWM	Superconducting warm section
TL	Transfer line
WCmp	(CHL) Warm compressor system

#### Ring Specific Subsystems

Coll	Collimator
Extr	Extraction
HEBT	HEBT
Inj	Injection
Ring	Ring
RTBT	RTBT

#### Target Systems Specific Subsystems

TRH	Remote handling system
D2O	Heavy water cooling subsys.
EDmp	Ring extract dump maint subsys)
He	Helium gas subsystem
Hg	Target mercury loop
IDmp	Ring injection dump maint subsys
LDmp	Linac beam dump maint subsys
LWS1	Target utilities Light Water Loop 1 for cooling after to the main Hg heat exchanger
LWS2	Target utilities Light Water Loop 2 for cooling after to the main Hg heat exchanger
LWS3	Target utilities Light Water Loop 3 for cooling after to the main Hg heat exchanger
NFSS	Nuclear facility safety significant system
Shld	Target shielding systems
TMod	Target moderator systems
TPS	Target Protection System

<del>Subsystem code</del>	<del>Subsystem description</del>
Subsystem Code	Subsystem Description

Tran	Target transport systems
Vac	Vessel vacuum subsystem

#### Instrument Specific Subsystems

BmLn	Incident instrument beam line
DAS	Data Acquisition System
FltPth	Flight path
Guide	Instrument neutron guide tubes
Inel1	Spectrometer, microvolt
Inel2	Spectrometer, 100 microvolt
Inel4	Spectrometer, wide angle chopper
Inel5	Spectrometer, large solid angle single crystal
Pow3	Powder diffractometer, long wavelength
Pow6	Powder diffractometer (strain; high resolution)
Pow7	Powder diffractometer (for glasses and liquids)
Ref1	Reflectometer, vertical refl. plane
Samp	Sample chamber
SANS2	Small angle neut scattering, Gen/lower Q high res
SCD1	Diffractometer, general purpose single crystal

#### Conventional Facilities Specific Subsystems

<del>BHWS</del>	<del>Building Heating Water System</del>
BHWS	Building heating water system
CA	Compressed air system
<del>CE</del>	<del>Central Exhaust enclosure</del>
CE	Central exhaust enclosure
CH	CHL building
<del>CL</del>	<del>Central Laboratory Office building</del>
CL	Central Laboratory and Office building
CNDR	Condenser water return
CNDS	Condenser water supply
CU	Central Utilities Building
CWR	Chilled Water Return
CWS	Chilled Water Supply
CT	Cooling Tower
DCR	Deionized Water Return
DWS	Deionized Water Supply
Elec	Electrical power and communication systems
FE	Front End building
FCryo	Facility cryogenic systems
FGas	Facility gas distribution systems
FVac	Facility vacuum system
FWD	Fire Water
<del>GND</del>	<del>Grounding system</del>
Gnd	Grounding system
GWTS	Gaseous waste treatment systems
HE	HEBT tunnel
HS	HEBT service area
HVAC	Heating, ventilation, and air conditioning systems
HWR	Heating Water Return
HWS	Heating Water Supply

<u>Subsystem code</u>	<u>Subsystem description</u>
<b>Subsystem Code</b>	<b>Subsystem Description</b>
KL	Klystron building
LLLW	Liquid low-level waste treatment systems
LN	Linac tunnel
NG	Natural gas systems
PW	Process Water System
PWTS	Process waste treatment systems
RG	Ring tunnel
RN	Ring Service Building
RS	RTBT Service Building
RT	RTBT tunnel
SC	Superconducting RF
SD	Storm Drain
ST	Site
SW	Sanitary Water System
SS	Sanitary Sewer
TA	Target
TB	Target Services Building
TS	Technical Services Building
Integrated Controls Systems	
EPS	Equipment Protection System
ICS	Integrated Control System
PPS	Personnel Protection System

**Table 5. Device type**

Device code	Device code description
-------------	-------------------------

**Table 5. Example device qualifiers**

Device Qualifier Code	Device Qualifier Code Description
Cs	Cesium
He	Helium
Hg	Mercury
H2	Hydrogen
H2O	Water
N2	Nitrogen

**Table 6. Device type**

Device Code	Device Code Description
Abs	Absorber
AHU	Air handling unit
Aprt	Aperture
Anod	Anode
BCM	Beam current monitor
BCS	Beam control system
BG	Bourdon gauge
BIG	Beam in gap monitor
BIGK	Beam in gap kicker
Bldg	Building
BLM	Beam loss monitor
BPM	Beam position monitor
BPMH	Beam position monitor, horizontal
BPMRF	RF beam position monitor
BPMV	Beam position monitor, vertical
Cab	Instrument and control cabinets
Cbl	Cable
Cath	Cathode
Cav	RF cavity
Es	Cesium
CCG	Cold cathode gauge
Chllr	Chiller
ClIr	Collar
Cmp	Compressor
Coll	Collimator
Con	Conductivity
CVG	ConVeetron Gauge
Coll	Collimator
CP	CryoPump
Damp	Damper
DCBPM	DC beam position monitor
DCH	Dipole magnet, corrector, horizontal
DCV	Dipole magnet, corrector, vertical
DEC	Decapole magnet
DH	Dipole magnet, horizontal
DMC	Dipole-multipole magnet, corrector
DMCH	Dipole-multipole magnet, corrector, H

Device Code	Device Code Description
DMCV	Dipole-multipole magnet, corrector, V
DP	Diffusion pump
Dr	Door
Drvr	Driver
Ds	Door switch
DV	Dipole magnet, vertical
ECV	Electric Control Valve
EKick	Extraction kicker
ExSpt	Extraction Septum
Fan	Fan
FBCM	Fast Beam Current Monitor
FBLM	Fast Beam Loss Monitor
Fil	Filament
Fltr	Filter
<del>FLV</del>	<del>Foreline valve</del>
FLV	Foreline valve
FLVV	Foreline vent valve
FV	Fast valve
FS	Flow Switch
Gnd	Ground
GV	Gate Valve
<del>Grid</del>	<del>Grid bias (bias) power supply</del>
<del>He</del>	<del>Helium</del>
<del>Hg</del>	<del>Mercury</del>
Grid	Grid (bias)
HMM	Higher momentum monitor
Htr	Heater
<del>H2</del>	<del>Hydrogen</del>
<del>H2O</del>	<del>Water</del>
Hub	Ethernet hub
HX	Heat exchanger
IG	Ion gauge
IkickH	Horizontal Injection kicker
IKickV	Vertical Injection kicker
InjSpt	Injection Septum
IOC	Input Output Controller
IP	Ion pump
IPA	Intermediate Power Amplifier
IPM	Ionization probe monitor
IPMH	Ionization probe monitor, H
IPMV	Ionization probe monitor, V
IX	Ion exchanger
Man	Manifold
Match	Matcher
Mix	Agitators, mixers
Mot	Motor
Mod	Modulator
MV	Manual valve
NEGP	Non-evaporable getter pump
<del>N2</del>	<del>Nitrogen</del>
NetSw	Network switch
Oct	Octupole magnet
OCH	Octopole magnet, corrector, H
OctH	Octupole magnet, horizontal

Device Code	Device Code Description
OctV	Octupole magnet, vertical
<del>OPS</del>	<del>OverPressure Sensor</del>
OCV	Octopole magnet, corrector, V
OPS	Over Pressure Sensor
PA	Power amplifier
Pen	Penetration
PG	Pirani gage
Pipe	Pipe
PIV	Pump isolation valve
PLC	Programmable Logic Controller
Plt	Plate
Pmp	Pump
PrM	Beam profile monitor
PrMH	Beam profile monitor, horizontal
PrMV	Beam profile monitor, vertical
PS	Power supply
PSL	Pressure switch, low
PSH	Pressure switch, high
Q	Quadrupole magnet
QC	Quadrupole magnet, corrector
QCH	Quadrupole magnet, corrector, H
QCV	Quadrupole magnet, corrector, V
QH	Quadrupole magnet, horizontal
QS	Quadrupole magnet, skew
QSC	Quadrupole magnet, skew, corrector
QSCH	Quadrupole magnet, skew, corrector, H
QSCV	Quadrupole magnet, skew, corrector, V
QSH	Quadrupole magnet, skew, horizontal
QSV	Quadrupole magnet, skew, vertical
QTH	Quadrupole magnet trim, H
QTV	Quadrupole magnet trim, V
QV	Quadrupole magnet, vertical
Reg	Regulator
RF	Radio Frequency (amplifier, etc)
RGA	Residual gas analyzer
RP	Roughing pump
<del>Rs</del>	<del>Resistivity</del>
RV	Roughing valve
SC	Speed controller
Scrp	Scraper
SGV	Sector gate valve
Shld	Shield
Scrn	Screen
Sptm	Septum
SPX	Speed expander
Steer	Steering electrodes
SX	Sextupole magnet
SXH	Sextupole magnet, horizontal
SXS	Sextupole magnet, skew
SXSCH	Sextupole magnet, skew, corrector, horizontal
SXSCV	Sextupole magnet, skew, corrector, vertical
SXSH	Sextupole magnet, skew, horizontal
SXSV	Sextupole magnet, skew, vertical
SXV	Sextupole magnet, vertical

<b>Device Code</b>	<b>Device Code Description</b>
TCG	<del>Thermocouple (vacuum) gage</del>
TCG	Thermal conductivity gage
Tnk	Tanks, receivers
TMK	Tune monitor kicker
TMP	Turbomolecular pump
TMPS	Turbomolecular pump station
Tun	RF Tuner
TSP	Titanium sublimation pump
Twr	Tower
VFM	Video foil monitor
Vlt	Vault
Vlv	Valve
Vrc	Variac (filament variable transformer)
VS	Vacuum sector
Vsl	Vessel
VV	Vent Valve
WCM	Wall current monitor
WCMRF	RF wall current monitor
WS	Wire scanner
WSH	Wire scanner, H
WSV	Wire scanner, V
WvG	Waveguide

**Table 6. Signal type**

<b>Signal code</b>	<b>Signal code description</b>
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**Table 7. Example Signal Qualifiers**

<b>Signal Qualifier Code</b>	<b>Signal Qualifier Code Description</b>
Cs	Cesium
H2	Hydrogen
H2O	Water
He	Helium
Hg	Mercury
N2	Nitrogen
Neg	Negative

**Table 8. Signal type**

<b>Signal Code</b>	<b>Signal Code Description</b>
Acc	Acceleration
AGnd	Analog ground
AH	Aperature, H
Ang	Angle
Aprt	Aperature
AV	Aperature, V
B	Field
Clk	Clock
Cnd	Conductivity
Cmd	Command (e.g. start/stop)
Ctl	Control (e.g. on/off)

<b>Signal Code</b>	<b>Signal Code Description</b>
DGnd	Digital ground
Dr	Door (e.g. interlock)
DP	Differential pressure
Err	Error
Flt	Fault
FltS	Fault summary
Flw	Flow (analog or digital)
Fn	Function
G	Gain
Hor	Horizontal (e.g. BPM horizontal position)
Ver	Vertical (e.g. BPM vertical position)
Hall	Hall probe
Ilk	Interlock
I	Current
Cmd	Command
Cur	Beam current
Lim	Limit
Lcl	Local (/Remote)
Lk	Leak
Lvl	Level
OI	Over-current
OReg	Out of regulation
OT	Over-temperature
OV	Over-voltage
P	Pressure
pH	pH
Pos	Position
UPos	Upstream position (e.g. collimator upstream pos)
Pwr	Power
Rad	Radiation
Rst	Reset
Rs	Resistivity
Spd	Speed
Sts	Status
Tim	Time
T	Temperature
V	Voltage
DPos	Downstream position (e.g. collimator downstrm pos)
Pr	Profile (vector or array) (e.g. horiz profile mon)

**Table 9. Signal Suffix**

<b>Signal Suffix</b>	<b>Signal Suffix Description</b>
Closed	Closed
Cmd	Command (generally binary)
DAC	DAC reference
Hor	Horizontal
H	High
HH	High-high
In	Inlet
L	Low
LL	Low-low
Open	Open
Out	Outlet
Set	Setpoint (generally analog)
Ver	Vertical

**7:Table 10: Instance Numbering**

Subproject	Instance Numbering
Front End	<p>Some devices span all the Front End subsystems and therefore will appear as generic "Front End" devices.</p> <p>Examples from Front End: FE</p> <p>FE:Chllr_2 Front End; H2O loop 4Chiller 2</p> <p>FE_Ctl:IOC_1 Front End; IOC 1</p> <p>Most devices are associated with particular subsystems, and follow the general guidelines.</p> <p>Example from Source:</p> <p>Examples from Source:</p> <p>Src1:Ovn Source 1; Oven</p> <p>Src1:RF Source 1; RF</p> <p>Src:Cs_Htr Source; Cesium Heater</p> <p>Example from LEBT:LEBT1:L3V LEBT 1; Lens 3, Vertical</p> <p>LEBT:Focus_1 LEBT; Focus 1</p> <p>Example from MEBT:MBT1:QH01 MEBT1; Quad 1, Horizontal</p> <p>MBT1:Scnr02 MEBT1; Scanner 2</p> <p>MBT1:Bneh MEBT1; Buncher</p> <p>MBT1:BPM03 MEBT1; Beam Position Monitor 3</p> <p>MBT1:FC04 MEBT1; Faraday Cup 4</p> <p>MEBT:QH_1 MEBT; Quadrupole 1, Horizontal</p> <p>Example from MEBT:MBT1:QH01 MEBT1; Quad 1, Horizontal</p> <p>MBT1:Scnr02 MEBT1; Scanner 2</p> <p>MBT1:Bneh MEBT1; Buncher</p> <p>MBT1:BPM03 MEBT1; Beam Position Monitor 3</p> <p>MBT1:FC04 MEBT1; Faraday Cup 4</p> <p>Src_Vac:TMP_1 First turbo pump located on the source</p> <p>Examples from RFQ:</p> <p>RFQ1:Kly RFQ1; Klystron</p> <p>RFQ1_Mod1AL:Tnr RFQ1; Module 1, Section A, Left; Tuner</p>
Front End	<p>Some devices span all the Front End subsystems and therefore will appear as generic "Front End" devices.</p> <p>Examples from Front End:</p> <p>FE:Chllr_2 Front End; Chiller 2</p> <p>FE_Ctl:IOC_1 Front End; IOC 1</p> <p>Most devices are associated with particular subsystems, and follow the general guidelines.</p>

Subproject	Instance Numbering
	<p>Example from Source: Src:Cs_Htr                      Source; Cesium Heater</p> <p>Example from LEBT: LEBT:Focus_1                      LEBT; Focus 1</p> <p>Example from MEBT: MEBT:QH_1                      MEBT; Quadrupole 1, Horizontal</p> <p>Example from MEBT: Src_Vac:TMP_1                      First turbo pump located on the source</p>
Linac	<p>The linac is divided into ever smaller components as follows: modules, segments, cavities, cells. Linac devices should be instantiated using the number of the <i>preceding</i> segment. For example:</p> <p>CCL:QH122                      Horizontally focusing quadrupole after segment 122</p> <p>CCL:BPM122                      Beam position monitor located after segment 122</p> <p>CCL:QH123                      Horizontally focusing quadrupole located after segment 123</p> <p>CCL:PS_QH123                      Power supply powering QH123</p> <p>CCL:QV124                      Vertically focusing quadrupole after segment 124</p> <p>CCL:DCV124                      Vertical Steering Magnet (Dipole Corrector - Vertical) after segment 124</p> <p>CCL:Tor124                      Toroid located after segment 124</p> <p>CCL:PrMH125                      Horizontal Profile Monitor after segment 125</p> <p>CCL_Vac:IG156                      Ion Gauge located after segment 156</p> <p>Example for vacuum systems:</p> <p>DTL_Vac:IG_2                      Ion gauge located on DTL tank 2</p>
Ring	<p><del>Ring magnets and power supplies instances will be assigned as follows. The ring lattice consists of four superperiods, each containing a 90-degree arc and a long-straight section. The four superperiods are labeled A, B, D, and run sequentially along the beam direction from the beginning of one arc to the beginning of the next. The order of magnets in each superperiod X is DHX1, QVX1, ..., QHX10, QVX11, QHX12 where D and Q denote dipoles and quadrupoles, and H and V refer to the horizontal and vertical planes. The long-straight sections in superperiod X run from QHX8 through QHX12.</del></p> <p><del>Devices in the beam transport lines will be labeled similarly except that there will be</del></p>

Subproject	Instance Numbering
	<p>no superperiod. Devices will be numbered sequentially from a starting point.</p> <p>Examples of Ring power supply devices follow:</p> <p>Ring_PS:DVA3 ————— Ring, Power Supply, Dipole Vertical, superperiod A, #3</p> <p>Ring_PS:QHB1 ————— Ring, Power Supply, Quadrupole, Horiz., superperiod B, #1</p> <p>Ring_PS:DCHA4 ————— Ring, Power Supply, Dipole Corrector Horiz, #4</p> <p>Instance designations for ring equipment not directly related to a specific ring or transport line location will be simply assigned a sequential number.</p> <p>Examples of ring vacuum devices:</p> <p>Ring1_Vac:FV1</p> <p>HEBT_Vac:IP3</p> <p>RTBT_Vac:SGV2</p> <p>Ring1_Vac:TSP2</p> <p>Examples of ring diagnostic devices:</p> <p>Ring1_Diag:BCM1 ————— Ring, Diag, BCM, #1</p> <p>Ring1_Diag:BLM5 ————— Ring, Diag, BLM, #5</p> <p>Ring1_Diag:BPMH1 ————— Ring, Diag, BPMH, #1</p> <p>Examples of ring RF devices:</p> <p>Ring1_RF:Cav</p> <p>Ring1_RF:PA</p> <p>Examples of other ring devices:</p> <p>HEBT:Colim1 — HEBT, Collimator#1</p> <p>HEBT:Colim2 — HEBT, Collimator#2 Downstream position</p> <p>Example for vacuum systems:</p> <p>HEBT_Vac:SGV_10 — Sector valve located after quadruple QH10.</p>
Ring	<p>Ring magnets and power supplies instances will be assigned as follows. The ring lattice consists of four superperiods, each containing a 90 degree arc and a long straight section. The four superperiods are labeled A, B, D, and run sequentially along the beam direction from the beginning of one arc to the beginning of the next. The order of magnets in each superperiod X is DHX1, QVX1, ..., QHX10, QVX11, QHX12 where D and Q denote dipoles and quadrupoles, and H and V refer to the horizontal and vertical</p>

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Target Systems	The device and instance naming convention should be based on the convention in IEEE 803.1. Instance numbers should be as follows:												



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